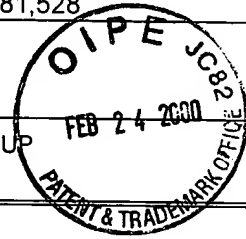


FORM PTO-1449 (Rev. 2-32) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE Information Disclosure Statement by Applicant (Use several sheets if necessary)	ATTY. DOCKET NO. YAO-V04302	SERIAL NO 09/381,528
	Applicant Yoshinao Taketomi et al.	
	FILING DATE January 4, 2000	GROUP



FOREIGN PATENT DOCUMENTS

Exmr Initial		Document Number	Date	Country	Class	Sub Class	Translation YES NO
	✓	61-144690	07/02/1986	Japan			X
	✓	6-69964	09/30/1994	Japan			X
		2598406	01/09/1997	Japan			X
bc	✓	62-63983	03/20/1987	Japan (with English abstract)			
	✓	2-186319	07/20/1990	Japan (with English abstract)			
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bc	1) ✓	International Search Report dated July 28, 1998 for related application PCT/JP98/01148
bc	2)	Yoshinao Taketomi et al., "Reflection hologram for reconstructing deep images", OPTICS LETTERS, Vol. 22, No. 22, November 15, 1997
bc	3) ✓	Yoshinao Taketomi et al., "Deep image reconstruction of a reflection hologram using a fluorescent lamp", 9 pages
bc	4)	"Report on Research and Study on Development of Large-Scale Hologram System (in Japanese)", Tokyo, Issued by Japan Society for the Promotion of Machine Industry Shin-Kikai System Center, March 1978, Page 116, lines 7-9; Figs 4.4.4
bc	5)	Yoshinao Taketomi et al., "A hologram that can reconstruct deep images, OPTICS JAPAN 97, 10/1/1997

Examiner 	Date Considered 10-11-2000
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Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.